

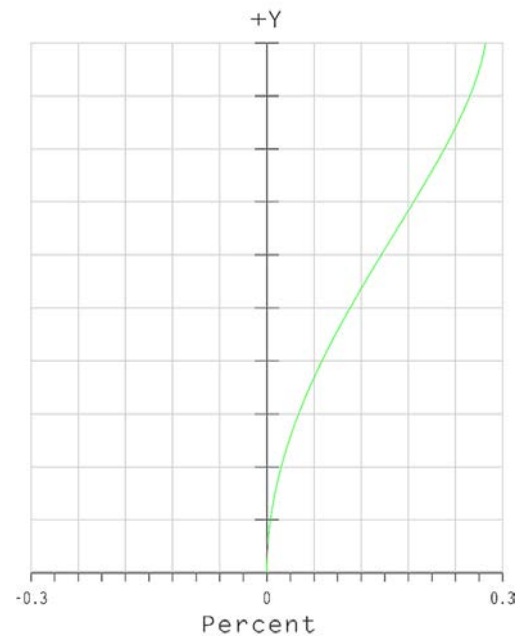
DATA SHEET



specifications

article number	S5LPJ6050
design wavelength [nm]	450-700
magnification (+/-5%)	0.246
working distance [mm] (+/-2%)	180.0
object size [mm]	26 x 19.5
at a chip size of [mm]	6.4 x 4.8 (1/2")
distortion [%]	0.12
object size [mm]	35.7 x 26.8
at a chip size of [mm]	8.8 x 6.6 (2/3")
distortion [%]	0.2
object size [mm]	52 x 39
at a chip size of [mm]	12.8 x 9.6 (1")
distortion [%]	0.3
max. telecentricity error [°]	0.07
numerical aperture	0.02
weight [kg]	1.60
flange back distance [mm]	17.53
accessory	S5SET0020, S5SET6030

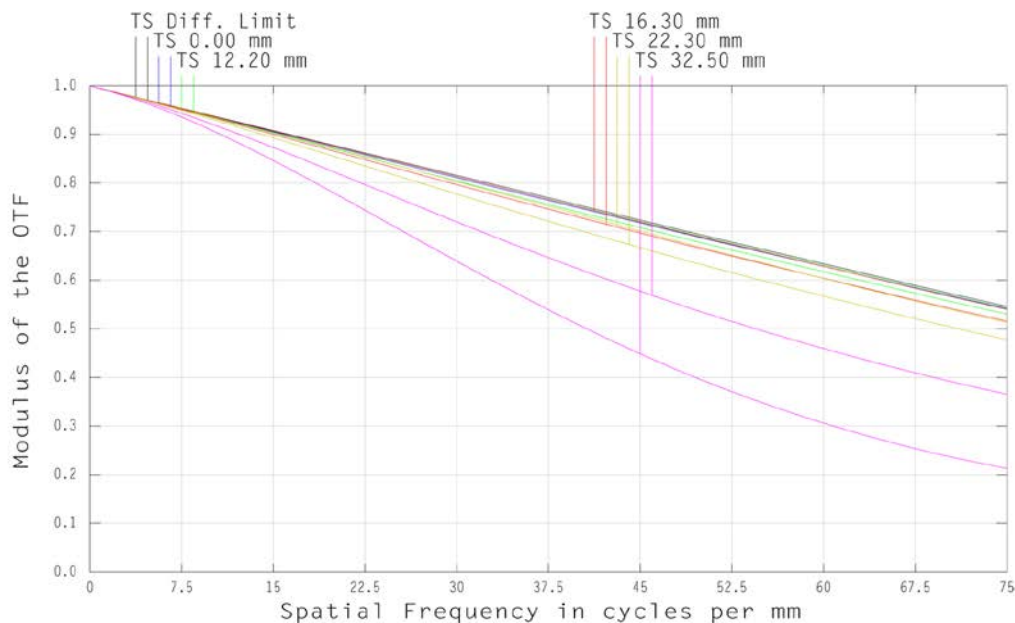
Distortion for 586 nm



x = distortion

y = max. field

MTF for various object heights at 586 nm



T. tangential

S. sagittal

graphs and data given by design.

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